

jp02088782/pn

L1 ANSWER 1 OF 1 WPINDEX COPYRIGHT 2006 THE THOMSON CORP on STN  
ACCESSION NUMBER: 1990-143268 [19] WPINDEX  
DOC. NO. CPI: C1990-062868  
TITLE: Prodn. of diamond coated member - by gas phase etching  
cermet substrate with carbon mon oxide, steam and  
hydrogen halide.  
DERWENT CLASS: E36 L02 M13  
PATENT ASSIGNEE(S): (HITG) BABCOCK-HITACHI KK; (HITA) HITACHI LTD  
COUNTRY COUNT: 1  
PATENT INFORMATION:

PATENT NO	KIND	DATE	WEEK	LA	PG	MAIN	IPC
JP 02088782	A	19900328	(199019)*				<--

APPLICATION DETAILS:

PATENT NO	KIND	APPLICATION	DATE
JP 02088782	A	JP 1988-239771	19880927

PRIORITY APPLN. INFO: JP 1988-239771 19880927  
INT. PATENT CLASSIF.: C23F004-00; C23F017-00  
BASIC ABSTRACT:

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A cermet substrate is subjected to gas phase etching treatment with at least one of carbon monoxide, steam and hydrogen halogenide selectively on binder of Co and/or Ni existing in surface, and formed with diamond film by using partic same gas of CO + H2 within same appts.

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FILE SEGMENT: CPI  
FIELD AVAILABILITY: AB; DCN  
MANUAL CODES: CPI: E31-N03; L02-H04; L02-J01B; M13-E02